FORM PTO 1449 (*modified*)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

OIPE JC139 JAN 11 2002 PATENT & TRADEMARK OFFICE

ATTY DOCKET NO.	APPLICATION NO.
03500.015881	09/977,972
APPLICANT: Yutaka Kagawa t al.	
FILING DATE: Octob r 17, 2001	GROUP: ~~1733~~ 1734

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

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FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	62-213399	09/19/87	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

		R. Herino et al. "Microstructure of Porous Silicon and its Evaluation with Temperature", Mater. Lett., vol. 2(6A & B), pp. 519-523 (1984).

EXAMINER _____ DATE CONSIDERED 8/25/03

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form #62

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